

# DECLARATION

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name,

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

## Vacuum Processing for Fabrication of Superconducting Thin Films Fabricated by Metal-Organic Processing

the specification of which (I authorize Choate, Hall & Stewart to check one of the following, three choices, and fill in the blanks, if applicable):

\_\_\_\_\_ is attached hereto

X was filed on July 13, 2002 as Application Serial No. 10/194,561 (I authorize Choate, Hall & Stewart to fill in this information) and amended on \_\_\_\_\_ (if applicable).

\_\_\_\_\_ was filed as PCT international application No. \_\_\_\_\_, on \_\_\_\_\_ and was amended under PCT Article 19 on \_\_\_\_\_ (if applicable).

I hereby state that I have reviewed and understood the contents of the above-identified specification, including the claims, as amended by any amendment referred to above.

I acknowledged the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations, §1.56.

I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

Prior Foreign Application(s):

Priority Claimed

_____ (Number)	_____ (Country)	_____ (Day/Month/Year/Filed)	Yes	No
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_____ (Number)	_____ (Country)	_____ (Day/Month/Year/Filed)	Yes	No
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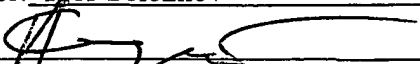
(Application Serial No.)	(filing date)	(status-patented, pending, abandoned)

(PCT Appl. No.)	(filing date)	(status-patented, pending, abandoned)
2006/000000	2006-01-01	patented
2006/000001	2006-01-01	pending
2006/000002	2006-01-01	abandoned

Provisional Application(s):

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United State Code and that such willful false statements may jeopardize the validity of the application or any patents issued thereon.

1) Full name of first inventor: Igor Seleznev

Inventor's signature:  Date: 07/30/02

Mailing Address: 540 Memorial Dr. Apt 1607 Cambridge, MA

Citizenship: Russia

Residence (if different from mailing address): City: Cambridge State: MA

2) Full name of second inventor: Michael J. Cima

Inventor's signature: \_\_\_\_\_ Date: \_\_\_\_\_

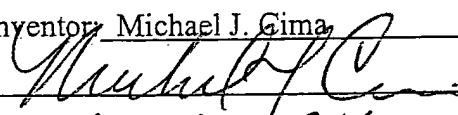
Mailing Address: \_\_\_\_\_

Citizenship: \_\_\_\_\_

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1) Full name of first inventor: Igor Seleznev  
Inventor's signature: \_\_\_\_\_ Date: \_\_\_\_\_  
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2) Full name of second inventor: Michael J. Gima  
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